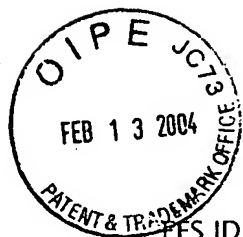


Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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EFS ID:

55539

Application ID:

10679844



Title of Invention:

METHODS AND SYSTEMS FOR
INSPECTING RETICLES USING
AERIAL IMAGING AT OFF-
STEPPER WAVELENGTHS

First Named Inventor:

Stan Stokowski

Domestic/Foreign Application:

Domestic Application

Filing Date:

2003-10-06

Effective Receipt Date:

2004-02-13

Submission Type:

Information Disclosure
Statement

Filing Type:

Confirmation number:

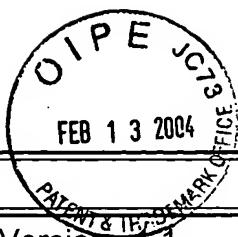
3733

Attorney Docket Number:

5589-04201


Total Fees Authorized:

Digital Certificate Holder: cn=Kevin L. Daffer,ou=Registered Attorneys,ou=Patent and Trademark
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Title of Invention	METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS									
<p>Application Number: 10/679844 </p> <p>Date: 2003-10-06</p> <p>First Named Applicant: Stan Stokowski</p> <p>Confirmation Number: 3733</p> <p>Attorney Docket Number: 5589-04201</p>										
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Submitted by:	Elec. Sign.	Sign. Capacity								
Kevin L. Daffer Registered Number: 34146	Kevin L. Daffer	Attorney								
<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>5589-04001IDS2-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	5589-04001IDS2-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	5589-04001IDS2-usidst.xml									
	us-ids.dtd									
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Comments										

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of
Invention

METHODS AND SYSTEMS FOR INSPECTING RETICLES
USING AERIAL IMAGING AT OFF-STEPPER
WAVELENGTHS

Application Number: 10/679844
Confirmation Number: 3733
First Named Applicant: Stan Stokowski
Attorney Docket Number: 5589-04201
Search string: (6636301 or 6614520 or 6529621).pn.



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6636301	2003-10-21	Kvamme et al.			
	2	6614520	2003-09-02	Bareket et al.			
	3	6529621	2003-03-04	Glasser et al.			

Signature

Examiner Name	Date